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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

NONE QVJ

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2003-43071 06/30/2003 ✓ QVJ

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/04/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		DRAWING 15	CLAIMS 20	CLAIMS 2
Verified and Acknowledged	<i>Quinton</i> Examiner's Signature <i>QVJ</i> Initials				

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## TITLE

Method for fabricating semiconductor device having trench type device isolation layer

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
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